

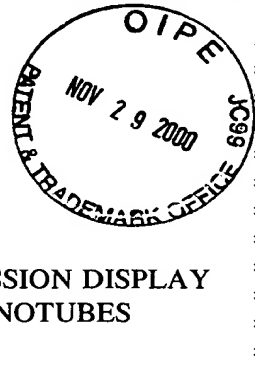
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Patent
Attorney's Docket No. 030681-248

#4 / IDS
2-14-01
R. Stokes

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of
Hang-woo LEE et al.
Application No.: 09/695,253
Filed: October 25, 2000



Group Art Unit: Unassigned
Examiner: Unassigned

For: TRIODE FIELD EMISSION DISPLAY
USING CARBON NANOTUBES

INFORMATION DISCLOSURE STATEMENT
TRANSMITTAL LETTER

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

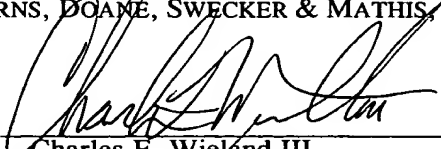
Enclosed is an Information Disclosure Statement and accompanying form PTO-1449 for the above-identified patent application.

- ☒ [X] No additional fee for submission of an IDS is required.
- ☐ [] The fee of \$180.00 (126) as set forth in 37 C.F.R. § 1.17(p) is also enclosed.
- ☐ [] A certification under 37 C.F.R. § 1.97(e) is also enclosed.
- ☐ [] A certification under 37 C.F.R. § 1.97(e), a petition requesting consideration of the information disclosure statement, and the petition fee of \$130.00 (122) as set forth in 37 C.F.R. § 1.17(i) are also enclosed.
- ☐ [] Charge \$_____ to Deposit Account No. 02-4800 for the fee due.
- ☐ [] A check in the amount of \$_____ is enclosed for the fee due.

The Commissioner is hereby authorized to charge any appropriate fees under 37 C.F.R. §§ 1.16, 1.17 and 1.21 that may be required by this paper, and to credit any overpayment, to Deposit Account No. 02-4800. This paper is submitted in duplicate.

Respectfully submitted,

BURNS, DOANE, SWECKER & MATHIS, L.L.P.

By: 
Charles F. Wieland III
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Date: Nov. 29, 2000

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Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. § 1.56, Applicants hereby submit the following information in conformance with 37 C.F.R. §§ 1.97 and 1.98.

Pursuant to 37 C.F.R. § 1.98, a copy of each of the documents cited are enclosed.

U.S. Patent No. 5,773,834, issued June 30, 1998, YAMAMOTO et al.;

Masako YUDASAKA, "Specific conditions for Ni catalyzed carbon nanotube growth by chemical vapor deposition", Appl. Phys. Lett. 67 (17), October 23, 1995, pages 2477-2479;

Kazuhiro YAMAMOTO, "New method of carbon nanotube growth by ion beam irradiation", Appl. Phys. Lett. 69 (27), December 30, 1996, pages 4174-4175; and

L. C. QIN, "Growing carbon nanotubes by microwave plasma-enhanced chemical vapor deposition", Appl. Phys. Lett. Vol. 72, No. 26, June 29, 1998, pages 3437-3439.

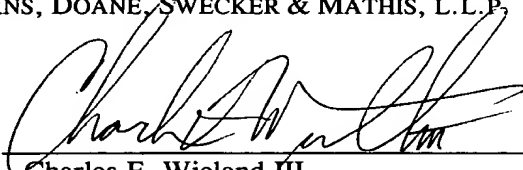
The documents are being submitted within 3 months of the filing or entry of the national stage of this application or before the first Office Action on the merits, whichever is later, therefore no fee or certification is required under 37 C.F.R. § 1.97(b).

To assist the Examiner, the documents are listed on the attached form PTO-1449. It is respectfully requested that an Examiner initialed copy of this form be returned to the undersigned.

Respectfully submitted,

BURNS, DOANE, SWECKER & MATHIS, L.L.P.

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